



TSMC-03-300

March 9, 2004

To: Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Avenue
Poughkeepsie, N.Y. 12603

Subject: | Serial No. 10/762,165 01/21/04 |
Huan-Liang Tzeng et al.
CENTER BALL O-RING
| _____ |

INFORMATION DISCLOSURE STATEMENT

Enclosed is Form PTO-1449, Information Disclosure Citation
In An Application.

The following Patents and/or Publications are submitted to
comply with the duty of disclosure under CFR 1.97-1.99 and
37 CFR 1.56.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
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P.O. Box 1450, Alexandria, VA 22313-1450, on March 16, 2004.

Stephen B. Ackerman, Reg.# 37761

Signature/Date

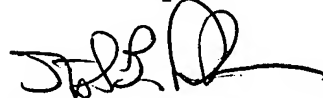
Stephen B. Ackerman 3/16/04

U.S. Patent 6,214,119 to Maher et al., "Vacuum Substrate Processing System having Multiple Processing Chambers and a Central Load/Unload Chamber," discusses plural plasma processing vessels and a wafer queuing station arrayed with a wafer transfer arm in a controlled environment.

U.S. Patent 4,923,584 to Bramhall, Jr. et al., "Sealing Apparatus for a Vacuum Processing System," discloses a sealing arrangement for a vacuum processing system for semiconductor wafers which is effective to apply a sealing force to a valve element between chambers of the processing system.

U.S. Patent 5,522,975 to Andricacos et al., "Electroplating Workpiece Fixture," discusses a fixture for supporting a workpiece in a processing cell including a frame and cooperating workpiece holder.

Sincerely,

A handwritten signature in black ink, appearing to read 'SBA', with a stylized flourish extending to the right.

Stephen B. Ackerman,
Reg. No. 37761

Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION.

(Use several sheets if necessary)

Doc No (Number) (Optional)

TSMC-03-300

Asst. Secy. of the Navy

10 | 762,165

Logitcan!

Huan-Liang Tzeng et al.

Filing Date

01/21/04

Group 27 Unit

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Portion or Pages, Etc.)

[illegible]

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.